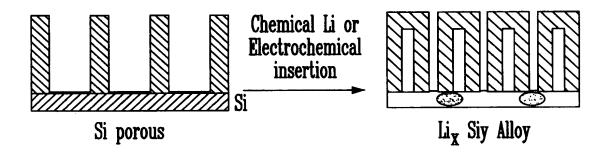
APPLN. FILING DATE: DECEMBER 22, 2005
TITLE: PROCESS FOR THE PREPARATION OF AN ELECTRODE FROM A POROUS MATERIAL, ELECTRODE THUS OBTAINED AND CORRESPONDING ELECTROCHEMICAL SYSTEM INVENTOR(s): KARIM ZAGHIB ET AL.
ATTY. DKT. No.: 032256-031 SHEET 1 OF 4

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## Silicium Patent

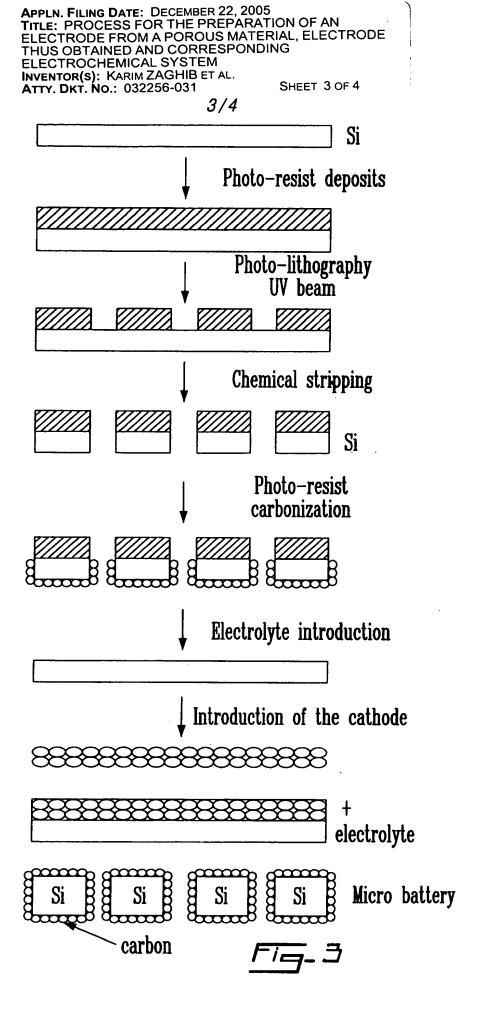


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ATTY. DKT. NO.: 032256-031 SHEET 2 OF 4

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## Silicium Patent

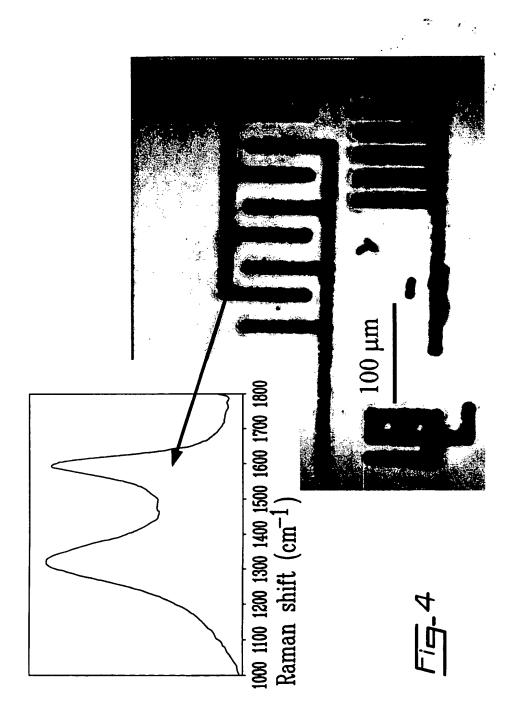
	Electrochemical attack in a fluorinated bath	
Si		Si porous (75% porosity)



APPLN. FILING DATE: DECEMBER 22, 2005
TITLE: PROCESS FOR THE PREPARATION OF AN ELECTRODE FROM A POROUS MATERIAL, ELECTRODE THUS OBTAINED AND CORRESPONDING ELECTROCHEMICAL SYSTEM INVENTOR(s): KARIM ZAGHIB ET AL.
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